

<b>Notice of References Cited</b>		Application/Control No. 10/796,201	Applicant(s)/Patent Under Reexamination SEGAWA ET AL.	
		Examiner DANIEL C. MCCRACKEN	Art Unit 1793	Page 1 of 1

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))  
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